

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/023,825 Confirmation No. 8239  
Applicant : Jorge A. Kitt et al.  
Filed : 12/19/2001  
TC/A.U. : 2829  
Examiner : Russell M. Kobert  
Docket No. : TI-23892  
Customer No. : 23494  
Title : METHOD TO IMPROVE SILICIDE FORMATION ON  
POLYSILICON

REQUEST FOR EXTENSION OF TIME

Commissioner of Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

## CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by  
facsimile to the U.S. Patent and Trademark Office at 703-872-9306 on  
the date shown below:

  
Jacqueline J. Garner, Reg. No. 36,144

January 20, 2004  
Date

Pursuant to 37 CFR 1.136(a), Applicant(s) respectfully petitions the Commissioner  
for an extension of the shortened statutory period for response in the above-identified  
Application.

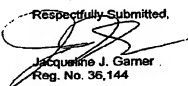
The fee for this extension is indicated below:

- ☒ One Month (\$110)  
☐ Two Months (\$420)  
☐ Three Months (\$950)  
☐ Four Months (\$1,480)

Please charge the fee to deposit account no. 20-0668. Any further necessary  
extension of time is hereby requested. Charge any and all fees to deposit account no. 20-  
0668. An original and two copies of this sheet are enclosed.

Texas Instruments Incorporated  
PO Box 655474, M/S 3999  
Dallas, TX 75265  
(214) 532-9348  
Fax: (972) 917-4418

Respectfully Submitted,

  
Jacqueline J. Garner  
Reg. No. 36,144